

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: INAZUKI, Yukio et al

Application No.:

Group:

Filed: August 6, 2002

Examiner:

For: PHASE SHIFT MASK BLANK, PHASE SHIFT MASK, AND METHOD OF
MANUFACTURE

COPY

LETTER

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

August 6, 2002
0171-0873P

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the applicant hereby claims the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
JAPAN	2001-237670	08/06/01

A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By: _____

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Attachment
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/nv